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Application Information

Title Line One:: SURFACE INSPECTION METHOD, SURFACE
Title Line Two:: INSPECTION APPARATUS, AND RECORDING
Title Line Three:: MEDIUM AND DATA SIGNAL FOR PROVIDING
Title Line Four:: SURFACE INSPECTION PROGRAM

09434503-011200

Total Drawing Sheets:: 10
Docket Number:: 105173

Continuity Information

>This application is a::
Application One::
Filing Date::
Patent Number::
which is a::
>>Application Two::
Filing Date::
Patent Number::

Prior Foreign Applications

Foreign Application One:: 11-006242
Filing Date:: January 13, 1999
Country:: Japan
Priority Claimed:: Yes
Foreign Application Two::
Filing Date::
Country::
Priority Claimed::
Foreign Application Three::
Filing Date::
Country::
Priority Claimed::